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	Application No.	Applicant(s)	
	09/765,608	HAYASHI ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Hai C Pham	2861	
The MAILING DATE of this communication appearable series allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOT (of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED i or other appropriate comm GHTS. This application is	n this application. If not included unication will be mailed in due cou	rse. THIS
1. X This communication is responsive to Amendment filed 04/0	<u>05/04</u> .		
2. X The allowed claim(s) is/are 1-8.			
3. \boxtimes The drawings filed on <u>22 January 2001</u> are accepted by the	e Examiner.		
4.	been received. been received in Application. been received in Application. been received in Application. being this communication to file ENT of this application. being the attached EX is reason(s) why the oath of the submitted. being the Amendment / Comment of the header according to 37 C is it of BIOLOGICAL MAT	on No Indicate the distance of the drawings in the report of the drawings in the front (not the backer). Indicate the distance of the drawings in the front (not the backer). Indicate the drawings in the submitted. Note the distance of the drawings in the submitted.	ements CE OF
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 6/25/03 & 7/24/03 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview S Paper No 8), 7. Examiner's	nformal Patent Application (PTO-15 Summary (PTO-413), /Mail Date s Amendment/Comment s Statement of Reasons for Allowal	·

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REASONS FOR ALLOWANCE

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1. The following is an examiner's statement of reasons for allowance: in light of Applicants' argument, claims 1, 3, 5, and 7 are patentable over the prior art patents and printed publications because of the specific new dots being formed at a center between adjacent light fluxes as a result of the adjacent light fluxes being overlapped with one another in the sub-scanning direction when an exposure intensity exceeds 50% of a maximum value and wherein a ratio of a static beam-spot diameter in a sub-scanning direction on the surface of the photosensitive body defined by 1/e2 of a maximum value in an exposure distribution of the beam spot to an interval between adjacent scan lines satisfies a certain relationship, which is not taught by the art of record alone or in combination.

Claims 2, 4, 6, and 8 are allowed because they are dependent form respective claims 1, 3, 5, and 7 above.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hai C Pham whose telephone number is (571) 272-2260. The examiner can normally be reached on M-F 8:30AM - 5:30PM.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen D Meier can be reached on (571) 272-2149. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

HAI PHAM
PRIMARY EXAMINER

Haichi Phane

May 1 2004

May 1, 2004